



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Gennari

Attorney Docket No.:
UCALP011X1/B02-005-3

Application No.: 10/716,266

Examiner: Unknown

Filed: November 17, 2003

Group: 2877

Title: METHOD OF LOCATING AREAS IN AN
IMAGE SUCH AS A PHOTO MASK LAYOUT
THAT ARE SENSITIVE TO RESIDUAL
PROCESSING EFFECTS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S.
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Kristina Gomez

REQUEST FOR CORRECTED FILING RECEIPT

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Sir:

Enclosed is a copy of the Filing Receipt for the above-identified patent application.
Please reprint the Filing Receipt as follows and mail the corrected copy to the undersigned.

In the Priority Data as Claimed by Applicant, CHANGE

"This application is a CIP of 10/241,242 09/10/2002" to

--This application is a CIP of 10/241,242 09/10/2002 AND claims priority to 60/322,381,
filed 09/11/01--.

Since this is a Patent Office typographical error, no fee should be due. However, the
Commissioner is authorized to charge any fees that may be due to Deposit Account 500388
(Order No. UCALP011X1).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP


Henry K Woodward
Registration No. 22,672

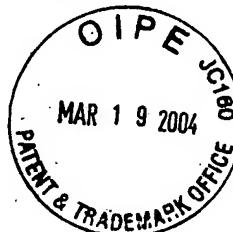
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APPL NO.	FILING OR 371 (C) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/716,266	11/17/2003	2877	1126	UCALP011X1/B02-005-3	19	35	4



022434
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CONFIRMATION NO. 6483

FILING RECEIPT



OC000000011625722

Date Mailed: 01/06/2004

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Applicant(s)

Frank E. Gennari, Berkeley, CA;

Assignment For Published Patent Application

The Regents of the University of California, Oakland, CA;

Domestic Priority data as claimed by applicant

This application is a CIP of 10/241,242 09/10/2002

AND claims priority to 60/322,381, filed 09/11/01

Foreign Applications

Projected Publication Date: To Be Determined - pending completion of Security Review

Non-Publication Request: No

SEARCHED	INDEXED
SERIALIZED	FILED
APR 1 2004	

Early Publication Request: No

Title

Method of locating areas in an image such as a photo mask layout that are sensitive to residual processing effects

Preliminary Class
356



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